



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 31, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG746517230

LABORATORY GROWN DIAMOND

SQUARE EMERALD CUT

6.96 X 6.89 X 4.68 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.03 CARATS

E

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

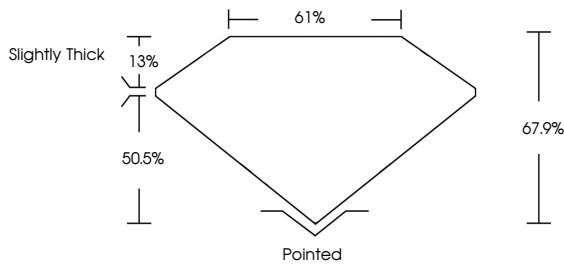
NONE

 LG746517230

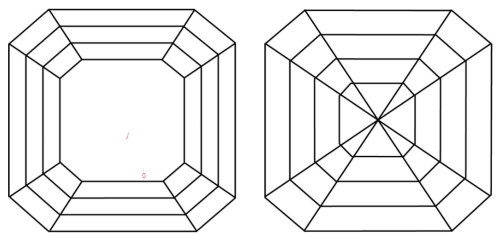
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

CLARITY

D	E	F	G	H	I	J	Faint	Very Light	Light
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FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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SQUARE EMERALD CUT

6.96 X 6.89 X 4.68 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

2.03 CARATS

E

VVS 2

67.9%

61%

Slightly Thick

Pointed

EXCELLENT

EXCELLENT

NONE

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